



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/647,297 Group Art Unit: 1771
Filing Date: August 26, 2003 Examiner: Hai Vo
Applicants: Hyun HUH et al.
Title: Polishing Pad Containing Embedded Liquid Microelements
and Method of Manufacturing the Same
Attorney Docket: 47881-000003/US

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

November 5, 2007

RESPONSE

Sir:

In response to the Office Action mailed August 3, 2007, the following remarks are respectfully submitted in connection with the above-identified application.

Listing of the Claims begins on page 2 of this Amendment.

Remarks begin on page 7 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	15	-	31	=	0
Independent	1	-	3	=	0